

Notice of References Cited

Application/Control No.

10/572,689

Applicant(s)/Patent Under
Reexamination
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Examiner

Michael C. Wimer

Art Unit

2821

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U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-5,757,327	05-1998	Yajima et al.	343/713
	B	US-			
	C	US-			
	D	US-			
	E	US-			
	F	US-			
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FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

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